

(19) World Intellectual Property Organization
International Bureau



(43) International Publication Date
6 July 2006 (06.07.2006)

PCT

(10) International Publication Number
WO 2006/071690 A1

- (51) International Patent Classification:
G01L 1/20 (2006.01) H01H 1/029 (2006.01)
- (21) International Application Number:
PCT/US2005/046434
- (22) International Filing Date:
19 December 2005 (19.12.2005)
- (25) Filing Language: English
- (26) Publication Language: English
- (30) Priority Data:
11/020,289 23 December 2004 (23.12.2004) US
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- (81) Designated States (unless otherwise indicated, for every kind of national protection available): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KM, KN, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, LY, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NG, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SM, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (unless otherwise indicated, for every kind of regional protection available): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LT, LU, LV, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Declarations under Rule 4.17:

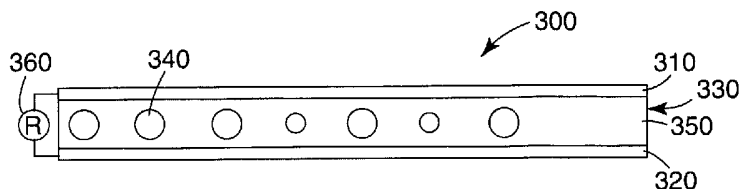
- as to applicant's entitlement to apply for and be granted a patent (Rule 4.17(ii))
- as to the applicant's entitlement to claim the priority of the earlier application (Rule 4.17(iii))

Published:

- with international search report

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: FORCE SENSING MEMBRANE



(57) Abstract: A force sensing membrane comprises (a) a first conductor that is movable toward a second conductor; (b) a second conductor; and (c) a composite material disposed between the first and second conductors for electrically connecting the first and second conductors under application of sufficient pressure therebetween; and (d) means for measuring dynamic electrical response across the force sensing membrane, the composite material comprising conductive particles at least partially embedded in an elastomeric layer, the conductive particles having no relative orientation and being disposed so that substantially all electrical connections made between the first and second conductors are in the z direction, and the elastomeric layer being capable of returning to substantially its original dimensions on release of pressure.

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FORCE SENSING MEMBRANE**FIELD**

This invention relates to force sensing membranes, to
5 devices comprising the force sensing membranes, and to
methods of force sensing using the force sensing membranes.

BACKGROUND

Force sensing membranes are used in various
10 applications to detect contact/touch, detect and measure a
relative change in force or applied load, detect and measure
the rate of change in force, and/or detect the removal of a
force or load.

Force sensing membranes typically consist of an
15 elastomer comprising conductive particles (the "elastomeric
layer") positioned between two conducting contacts. When
pressure is applied to one of the conducting contacts, the
conducting contact is pressed against the surface of the
elastomeric layer, and conduction paths are created. The
20 conduction paths are made up of chains of the conductive
particles that make a tortuous path through the elastomer.
Therefore, the concentration of conductive particles in the
elastomer must be above a certain threshold (that is, above
the percolation threshold) to make a continuous path. As
25 pressure is increased, greater numbers and regions of
contact between the conducting contact and the elastomeric
layer's surface are created. Thus, a greater number of
conduction paths through the elastomer and conductive
particles are created, and the resistance across the
30 elastomer layer is decreased.

SUMMARY

In view of the foregoing, we recognize that because the conduction paths in force sensing membranes of the prior art are made up of many conductive particle contacts, variations
5 in resistance and hysteresis can result.

Briefly, in one aspect, the present invention provides force sensing membranes wherein the concentration of conducting particles are less than the percolation threshold, and substantially all conduction paths are
10 through single particles. The force sensing membranes comprise (a) a first conductor that is movable toward a second conductor, (b) a second conductor, (c) a composite material disposed between the first and second conductors for electrically connecting the first and second conductors
15 under application of sufficient pressure therebetween, and (d) means for measuring dynamic electrical response (for example, resistance, conductance, current, voltage, and the like) across the force sensing membrane. As used herein, "means for measuring 'dynamic' electrical response" includes
20 any means for measuring electrical response that measures more than merely off/on.

The composite material comprises conductive particles at least partially embedded in an elastomeric layer. The conductive particles have no relative orientation and are
25 disposed so that substantially all electrical connections made between the first and second conductors are in the z direction (that is, substantially all electrical connections are in the thickness direction of a relatively planar structure, not in the in-plane (x-y) direction).

The elastomeric layer is capable of returning to substantially its original dimensions on release of pressure. As used herein, "capable of returning to
30 substantially its original dimensions" means that the layer

is capable of returning to at least 90 percent (preferably at least 95 percent; more preferably, at least 99 percent; most preferably 100 percent) of its original thickness within, for example, 10 seconds (preferably, within 1 second or less).

In another aspect, the present invention provides a force sensing membrane comprising (a) an elastomeric layer disposed on a first conductor, and (b) a composite layer comprising conductive particles at least partially embedded in an insulating material disposed on a second conductor.

At least one of the first and second conductors is movable toward the other conductor (that is, either the first conductor is movable toward the second conductor, or the second conductor is movable toward the first conductor, or both conductors are movable toward each other).

The conductive particles electrically connect the first and second conductors under application of sufficient pressure therebetween. The conductive particles have no relative orientation and are disposed so that substantially all electrical connections made between the first and second conductors are in the z direction.

The elastomeric layer is capable of returning to substantially its original dimensions on release of pressure.

The force sensing membranes of the invention therefore meet the need in the art for force sensing membranes with less variations in resistance and hysteresis than those made up of many conductive particle contacts.

In yet another aspect, the present invention provides methods of force sensing using the force sensing membranes of the invention.

DESCRIPTION OF DRAWINGS

Fig. 1 is a schematic side view of a force sensing membrane.

Figs. 2(a) and **(b)** are schematic side views of composite materials useful in a force sensing membrane of the invention.

Figs. 3(a), (b), (c), and (d) illustrate the use of a force sensing membrane of the invention using schematic side views of a force sensing membrane of the invention.

Fig. 4 is a schematic side view of another embodiment of a force sensing membrane of the invention.

Figs. 5(a) and **(b)** are schematic side views of another embodiment of a force sensing membrane of the invention.

Fig. 6 is a plot of force versus resistance on a log-log scale for a force sensing membrane of the invention described in Example 1.

While the invention is amenable to various modifications and alternative forms, specifics thereof have been shown by way of example in the drawings and will be described in detail. It should be understood, however, that the intention is not to limit the invention to the particular embodiments described. On the contrary, the intention is to cover all modifications, equivalents, and alternatives falling within the spirit and scope of the invention.

DETAILED DESCRIPTION

The force sensing membranes of the invention can be used in various applications to detect contact/touch, detect and measure a relative change in force or applied load, detect and measure the rate of change in force, and/or detect the removal of a load or force.

When sufficient pressure is applied to a force sensing membrane of the present invention, electrical contact is made between the conductors. For a broad range of pressures, the resistance (R) of the force sensing membranes typically varies with pressure (P) according to the relationship:

$$R \approx 1/P^n$$

wherein n is close to unity. Therefore, when R versus P is plotted on a log-log scale, a straight line can be obtained. Thus, the force sensing membranes of the invention are sensitive force/pressure sensors over a wide dynamic range of pressure. The variable resistance can be read out using any suitable means (for example, with an ohm meter, an array of light emitting diodes (LEDs), or audio signals with the appropriate circuitry).

To make electrical contact between the conductors, the present invention employs conductive particles preferably distributed between the conductors in such a manner that substantially all electrical contacts are through one or more single particles (that is, both conductors are in simultaneous electrical contact with the same particle or particles). The conductive particles are at least partially embedded in an elastomeric material. The elastomeric material allows for electrical contacts through greater numbers of conductive particles and for contact over greater regions of the conductive particles as pressure is increased. The elastomeric material also allows for the electrical connection to be broken when sufficient pressure between the conductors no longer exists. For example, the elastomeric material can be a resilient material that can be deformed to allow electrical contact to be made upon the application of pressure, and that returns the conductors to their initial separated positions when no pressure is

applied. The deformation of the elastomeric material will increase or decrease as the application of pressure is increased or decreased.

5 Distributing the conductive particles so that electric contacts are made via one or more single particles can have several benefits. Because the conductors are in electrical contact via single particles, there are at most only two contact points to contribute to contact resistance for each particle contact (a conductive particle contacting the top
10 conductor is one contact point, and the same conductive particle contacting the bottom conductor is another contact point), and this number of contact points remains consistent for each activation of a particular force sensing membrane. This can result in a relatively low contact resistance and a
15 more consistent, reliable, and reproducible signal every time the force sensing membrane is activated. Lower contact resistance gives rise to less signal loss, which ultimately results in a higher signal to noise ratio, which can result in more accurate force or pressure determinations in force
20 sensor devices.

Another advantage of single particle electrical contacts is the absence of particle alignment requirements and preferred particle-to-particle orientations. For example, application of a magnetic field during
25 manufacturing is not required to orient and align the particles, making manufacturing easier and less costly. In addition, when magnetic alignment is used, the conductive particles span the entire thickness of the resulting film, requiring another insulating layer to be applied so that the
30 overall construction is not conductive in the absence of pressure. The absence of particle alignment requirements can also improve durability relative to devices that employ aligned wires or elongated rods vertically oriented in the

thickness direction of the device that can be subject to bending and breaking upon repeated activation and/or relatively high applied forces. The absence of particle alignment and orientation requirements makes the force sensing membranes of the present invention particularly
5 suitable for applications where the membrane is to be mounted in curved, irregular, or otherwise non-flat configurations.

Force sensing membranes of the present invention can also be made very thin (for example, between about 1 μm and about 500 μm ; preferably, between about 1 μm and about 50 μm) because the gap between the conductors at their rest state (that is, with no externally applied pressure) need only be slightly larger than the largest conductive particles
10 disposed between the conductors. As such, relatively low particle loadings can be used while still maintaining reliable performance and sufficient resolution. The particles can also be distributed so that the activation force (that is, the force required to activate the force
15 sensing membrane) is uniform across the surface of the membrane. The ability to use lower particle density can also be a cost advantage because fewer particles are used.

Fig. 1 shows a force sensing membrane **100** that includes a first conductor in the form of a conductive layer **110**, a
25 second conductor in the form of a second conductive layer **120**, a composite material **130** between the first and second conductive layers, and means for measuring electrical response (shown here as resistance) across the force sensing
30 membrane **100**. At least one of conductive layers **110** and **120** is movable with respect to the second conductive layer, for example, by application of external pressure. The composite material **130** has conductive particles wholly or partially

embedded in an insulating elastomeric material. By
insulating, it is meant that the material is sufficiently
less conductive than the particles and the conductors so
that the electrical connection made upon application of
5 pressure is substantially reduced when no pressure is
applied. As used herein, "insulating" materials have a
resistivity greater than about 10^9 ohms.

Either of the conductive layers 110 or 120 can be a
conductive sheet, foil, or coating. The material(s) of the
10 conductive layers can include any suitable conductive
materials such as, for example, metals, semiconductors,
doped semiconductors, semi-metals, metal oxides, organic
conductors and conductive polymers, and the like, and
mixtures thereof. Suitable inorganic materials include, for
15 example, copper, gold, and other metals or metal alloys
commonly used in electronic devices, as well as transparent
conductive materials such as transparent conductive oxides
(for example, indium tin oxide (ITO), antimony tin oxide
(ATO), and like). Suitable organic materials include, for
20 example, conductive organic metallic compounds as well as
conductive polymers such as polypyrrole, polyaniline,
polyacetylene, polythiophene, and materials such as those
disclosed in European Patent Publication EP 1172831.

For some applications (for example, healthcare/medical
25 applications) it is preferable that the conductive layers be
permeable to moisture vapor. Preferably, the moisture vapor
transmission rate (MVTR) of the conductive layer is at least
about 400 g water/m²/24 hours (more preferably, at least
about 800; even more preferably, at least about 1600; most
30 preferably, at least about 2000) when measured using a water
method according to ASTM E-96-00.

A means for measuring dynamic electrical response
across the force sensor (not shown in **Fig. 1**) can be

electrically connected to conductive layers 110 and 120. Suitable means for measuring dynamic electrical response include, for example, ohmmeters and multimeters. The dynamic electrical response can be read out, for example, on the ohmmeter or multimeter, or by any other suitable means (for example, an array of light emitting diodes (LEDs) or an audio signal).

The conductors can be self-supporting or can be provided on a substrate (not shown in Fig. 1). Suitable substrates can be rigid (for example, rigid plastics, glass, metals, or semiconductors) or flexible (for example, flexible plastic films, flexible foils, or thin glass. Substrates can be transparent or opaque depending upon the application.

The composite material disposed between the conductors includes conductive particles at least partially embedded in an elastomeric material. The conductive particles are disposed so that when pressure is applied to the device to move one conductor relative to the other, an electrical connection can be made through single particles contacting both of the conductors.

Fig. 2(a) shows one example of a composite material 230 that includes conductive particles 240 partially embedded in an elastomeric layer 250. Fig. 2(b) shows an example of another composite material 231 that includes conductive materials 241 completely embedded in an elastomeric layer 251. While Figs. 2(a) and (b) serve to illustrate embodiments of a composite material useful in the present invention, any suitable arrangement where conductive particles are embedded fully or partially in any suitable ratio at any suitable position with respect to any particular surface of the elastomeric layer or material can be used. The present invention does not exclude composite

materials having isolated instances where conductive particles overlap in the thickness direction of the device.

Preferably, the largest conductive particles are at least somewhat smaller than the thickness of the layer of elastomeric material, at least when the particle size is measured in the thickness direction of the composite. This can help prevent electrical shorting.

Suitable conductive particles include any suitable particles that have a contiguously conductive outer surface. For example, the conductive particles can be solid particles (for example, metallic spheres), solid particles coated with a conductive material, hollow particles with a conductive outer shell, or hollow particles coated with a conductive material. The conductive material can include, for example, metals, conductive metal oxides, organic conductors and conductive polymers, semiconductors, and the like, and mixtures thereof. The core of coated particles can be solid or hollow glass or plastic beads, ceramic particles, carbon particles, metallic particles, and the like, and mixtures thereof. The conductive particles can be transparent, semi-transparent, colored, or opaque. They can have rough or smooth surfaces, and can be rigid or deformable.

The term "particles" includes spherical beads, elongated beads, truncated fibers, irregularly shaped particles, and the like. Generally, particles include particulate objects that have aspect ratios (that is, the ratio of the narrowest dimension to the longest dimension (for example, for a fiber the aspect ratio would be length: diameter) of 1:1 to about 1:20, and have characteristic dimensions in a range of about 1 μm to about 500 μm , depending upon the application. The conductive particles are dispersed in the composite material without any preferred orientation or alignment.

Suitable elastomeric materials include those that can maintain sufficient electrical separation between the conductors of force sensing membranes of the invention and that exhibit deformability and resiliency properties that allow the elastomeric material to be compressed to allow electrical contact of the conductors via one or more single particle contacts, to compress or deform in accordance with the amount of pressure applied, and to return the conductors to an electrically separated state when sufficient pressure is no longer being applied. Suitable elastomeric materials include, for example, both thermoplastic (linear or branched) and thermoset (crosslinked) polymers. Elastomeric materials can optionally include non-elastic polymers dispersed therein.

Preferably, the elastomeric material (in a fully cured state if a curable material) has a substantially constant storage modulus (G') over a large temperature range (more preferably, a substantially constant G' between about 0°C and about 100°C ; most preferably, a substantially constant G' between about 0°C and about 60°C). As used herein, "substantially constant" means less than about 50 percent (preferably, less than 75 percent) variation. Preferably, the elastomeric material has a G' between about 1×10^3 Pa/cm^2 and about 9×10^5 Pa/cm^2 and a loss tangent ($\tan \delta$) between about 0.01 and about 0.60 at 1 Hz at 23°C . It is also preferable that the elastomeric material be self-healing (that is, capable of healing itself when cracked, punctured, or pierced). It is also preferable that the elastomeric material is not substantially affected by humidity.

Suitable elastomeric materials include, for example, natural and synthetic rubbers (for example, styrene butadiene rubber or butyl rubber, polyisoprene,

polyisobutylene, polybutadiene, polychloroprene, acrylonitrile/butadiene as well as functionalized elastomers such as carboxyl or hydroxyl modified rubbers, and the like), acrylates, silicones including but not limited to polydimethylsiloxanes, styrenic block copolymers (for example, styrene-isoprene-styrene or styrene-ethylene/butylene-styrene block copolymer), polyurethanes including but not limited to those based on aliphatic isocyanate, aromatic isocyanate and combinations thereof, polyether polyols, polyester polyols, glycol polyols, and combinations thereof. Suitable thermoplastic polyurethane polymers are available from BF Goodrich under the Estane™ name. Thermoset formulations can also be used by incorporating polyols and/or polyisocyanates with an average functionality higher than two (for example, trifunctional or tetrafunctional components). Polyureas such as those formed by reaction of a polyisocyanate with a polyamine can also be suitable. Suitable polyamines can be selected from a broad class including polyether and polyester amines such as those sold by Huntsman under the Jeffamine™ name, and polyamine functional polydimethylsiloxanes such as those disclosed in U.S. Patent No. 6,441,118 (Sherman et al.); elastomeric polyesters such as those by DuPont under the Hytrel™ name; certain metallocene polyolefins such as metallocene polyethylene (for example, Engage™ or Affinity™ polymers from Dow Chemical, Midland MI) can also be suitable. Fluorinated elastomers such as Viton™ from DuPont Dow Elastomers can also be suitable. The elastomeric materials can be modified, for example, with hydrocarbon resins (for example, polyterpenes) or extending oils (for example, naphthenic oils or plasticizers), or by the addition of organic or inorganic fillers such as polystyrene

particles, clays, silica, and the like. The fillers can have a particulate or fibrous morphology. Preferably, the elastomeric material comprises a silicone (preferably a moisture cure thermoset) or a styrenic block copolymer.

5 For some applications (for example, healthcare/medical applications) it is preferable that the elastomeric material be permeable to moisture vapor. Preferably, the moisture vapor transmission rate (MVTR) of the elastomeric material is at least about 400 g water/m²/24 hours (more preferably, at least about 800; even more preferably, at least about 1600; most preferably, at least about 2000) when measured using a water method according to ASTM E-96-00.

10 Composite materials can be provided in any suitable manner. Generally, making or providing the composite material involves distributing the conductive particles and at least partially embedding the conductive particles in the elastomeric material. For example, the particles can first be distributed on a surface and the elastomeric material coated over, pressed onto, or laminated to the layer of particles. The surface of the particles are distributed onto can be a layer of the force sensing membrane, for example one of the conductors, or a carrier substrate that is removed after the particles are embedded into the elastomeric material. As another example, the particles can be dispersed in the elastomeric material and the resulting composite can be coated to form the composite material. As still another example, the elastomeric material can be provided as a layer, for example by coating, and then the conductive particles can be distributed on the layer of elastomeric material. The conductive particles can be embedded by pressing the particles into the layer of elastomeric material, with optional heating of the elastomeric material to allow the elastomeric material to

soften, or by distributing the particles on, and optionally pressing the particles into, the elastomeric material layer when the elastomeric material is in an uncured or otherwise softened state and subsequently hardening the elastomeric material layer by curing, cooling, or the like. Thermal, moisture, and light cure reactions can be employed, as well as two part systems.

Methods of dispersing the conductive particles include, for example, those disclosed in U.S. Patent App. Pub. No. 03/0129302 (Chambers et al.). Briefly, the particles can be dispensed onto a layer of the elastomeric material in the presence of an electric field to help distribute the particles as they randomly land on the layer. The particles are electrically charged such that they are mutually repelled. Therefore, lateral electrical connections and particle agglomeration are substantially avoided. The electric field is also used to create attraction of the particles to the film. Such a method can produce a random, non-aggregating distribution of conductive particles. The particles can be applied at a preselected density with a relatively uniform (number of particle per unit area) distribution of particles. Also, the web can be buffed to further aid in the particle distribution.

Other methods of dispersing the conductive particles can also be used. For example, the particles can be deposited in the pockets of micro-replicated release liners as disclosed in International Pub. WO 00/00563. The elastomeric material would then be coated on or pressed against this particle-filled liner.

Any other method for distributing or dispersing the particles can be used provided that the particles are so distributed in the composite material that substantially all electrical contacts made between the conductors of the force

sensing membrane are through one or more single particle contacts. As such, care should be taken to reduce or eliminate the occurrence of stacked particles in the composite (that is, two or more particles having overlapping positions in the thickness direction of the composite).

The methods used to place particles onto the medium should ensure that the contact between particles in the in-plane (x-y) direction is minimized. Preferably, no more than two particles should be in contact (for example, in a 30 cm² area). More preferably, no two particles are in contact with each other (for example, in a 30 cm² area). This will prevent any electrical shorting in the in-plane direction due to particle contact, and is especially preferred when the application requires multiple closely spaced electrodes.

Figs. 3(a), (b), (c), and (d) illustrate the use of a force sensing membrane of the invention in which electrical contact is achieved by physical contact through one or more single particles. Force sensing membrane **300** includes a first conductor **310**, a second conductor **320**, composite material **330** comprising conductive particles **340** in an elastomeric layer **350** disposed between the conductors, and means for measuring dynamic electrical response across the force sensing membrane **360**. As shown in **Fig. 3(a)**, when no pressure is applied between the conductors, the conductors **310** and **320** remain electrically isolated by the elastomeric layer **350**. As shown in **Fig. 3(b)**, when sufficient pressure **P** is applied to the first conductor **310**, an electrical contact can be made between the conductors **310** and **320** via single particle contacts. Single particle contacts are those electric contacts between the first and second conductors where one or more single conductive particles individually contact both the first and the second

conductors. As shown in **Fig. 3(c)**, when more pressure P' is applied to the first conductor **310**, the elastomeric layer **350** further compresses and more single particle contacts can be made. As shown in **Fig. 3(d)**, when all pressure is removed, the elastomeric layer **350** returns to substantially its original dimensions and no electric contacts are made.

The conductive particles can have a size distribution such that all the particles are not identical in size (or shape). In these circumstances, the larger conductive particles can make electrical contact before, or even to the exclusion of, smaller neighboring particles. Whether and to what extent this occurs depends on the size and shape distribution of the particles, the presence or absence of particle agglomeration, the loading density and spatial distribution of the particles, the ability for the movable conductor (or movable conductor/substrate combination) to flex and conform to local variations, the deformability of the particles, the deformability of the elastomeric material in which the particles are embedded, and the like. These and other properties can be adjusted so that a desirable number of single particle electrical contact per unit are made when sufficient pressure is applied between the first and second conductors. Properties can also be adjusted so that a desirable number of single particle electrical contact per unit are made when at one given amount of pressure versus a different amount of force/pressure applied between the first and second conductors.

In some embodiments, it can be preferable for the particle size distribution to be relatively narrow, and in some circumstances it can be preferable that all the particles are substantially the same size. In some embodiments, it can be desirable to have a bimodal distribution of particle sizes. For example, it can be

desirable to have two different types of particles, larger particles and smaller particles, dispersed in the composite material.

Fig. 4 shows another embodiment of a force sensing membrane of the invention. Force sensing membrane **400** includes a first conductor **410**, composite material **430** comprising conductive particles **440** in an elastomeric layer **450** disposed on a second conductor **420**, and means for measuring dynamic electrical response across the force sensing membrane **460**. Spacers **470** create a gap **480** (for example, an air gap) between the composite material **430** and the first conductor **410**. Adding a gap of air between the composite material and a conductor changes the sensitivity of the force sensing membrane, and can thus be useful for tailoring the sensor to specific applications. Alternatively, the gap can be filled with a non-conducting filler material. Filling the gap can provide advantages such as increased durability in force sensing membranes that have conductors that are prone to cracking and flaking (for example, transparent conductive layers) due to the protection that a filler material provides.

Force sensing membranes of the invention can also be tailored to specific applications by embossing the elastomeric layer (for example, to provide a microreplicated surface). Embossing the elastomeric layer can allow air to move freely in and out of the membrane, and can thus lower the activation force of the membrane. Embossing can also help prevent shorting. Alternatively, microspheres (for example, Expancel™ microspheres from Akzo Nobel) can be dispersed in the elastomeric layer.

Figs. 5(a) and 5(b) show embodiments of force sensing membrane according to the present invention that have a two-layer construction. In **Fig. 5(a)**, force sensing membrane **500**

includes an elastomeric layer 590 disposed on a first conductor 510, and a composite layer 530 comprising conductive particles 540 in an insulating material 550 disposed on a second conductor 520. Means for measuring dynamic electrical response across the force sensing membrane (not shown) can be electrically connected to the force sensing membrane. Preferably, the thickness of the composite layer is less than the average conductive particle size. The elastomeric layer disposed on the first conductor can help prevent electrical shorts (from unexpected electrode-particle-electrode electrical contacts) from occurring due to the composite layer being too thin.

In **Fig. 5(b)**, the conductive particles 540 have been compressed down (for example, by passing through a roll nip) so that at least some of them are always in contact with the second conductor 520. When the particles are nipped down and the thickness of the composite layer is controlled to be less than the average particle size, the activation force (that is, the force required to electrically connect the first and second conductors) is controlled by the thickness and properties of the elastomeric layer. The properties of the insulating material and the conductive particles of the composite layer have relatively little effect on the activation force. Thus, the force sensing membrane can be designed to have a particular activation force.

The insulating material can be any insulating, film-forming, curable material. The insulating material can be an elastomeric or non-elastomeric material. The insulating material can comprise, for example, urethanes, epoxies, acrylates, polyesters, polyolefins, polyamides, and the like, and mixtures thereof. Preferably, the insulating material is an elastomeric material that is capable of returning to substantially its original dimensions on

release of pressure. More preferably, the insulating material comprises an elastomeric material that has a substantially constant G' (in its fully cured state if a curable material) between about 0°C and about 100°C; most preferably, between about 0°C and about 60°C. Preferably, the elastomeric material has a G' between about 1×10^3 Pa/cm² and about 9×10^5 Pa/cm² and a loss tangent (tan delta) between about 0.01 and about 0.60 at 1 Hz at 23°C. It is also preferable that the elastomeric material be self-healing.

In the two-layer force sensing membranes of the invention, the elastomeric layer or the insulating material layer, or both, can be embossed.

The force sensing membranes of the invention can optionally comprise an overlay layer (for example, a plastic film or a foam layer) on one or both of the conductors. Typically, overlay layers are less than about 5 mm thick (preferably, less than about 2 mm thick) so that they do not affect the response of the force sensing membrane. Overlay layers are particularly useful when using force sensing membranes in medical applications (for example, to monitor pressure to prevent bedsores, diabetic foot ulcers, or excessive pressure under casts). Examples of useful overlay layers in medical pressure sensing applications include foam insoles for shoes, bed sheets, bandages, and socks.

The force sensing membranes of the invention can also optionally be encapsulated in a suitable material to provide water/moisture resistance.

The force sensing membranes of the invention are useful in many applications. For example, the force sensing membranes of the invention can be useful in healthcare applications such for alerting of excessive pressure under casts, or for monitoring pressure for the prevention of

bedsores and diabetic foot or leg ulcers. Preferably, if the force sensing membranes of the invention will be in contact or close proximity to a patient's skin, they are permeable to moisture vapor to allow moisture to evaporate
5 away from the skin.

Many individuals, for example, with diabetes experience poor sensation in the lower extremities as the disease progresses. Typically, these individuals use only visual observation to determine whether excessive pressure or skin
10 ulceration is occurring on the skin of the foot. Such ulcers are usually the result of pressure and/or shear forces applied to a particular point on the foot through standing or walking over time. The force sensing membranes of the present invention allow for pressure assessment of
15 the foot. For example, a force sensing membrane of the invention can be incorporated into (for example, sewn to, knitted into, adhesively or thermally bonded to, attached to by a hook and loop device, inserted into a pocket, or incorporated into by any suitable means) a sock, bandage, or
20 insole to measure pressure on the foot area of interest. The membrane can be electrically connected to a microprocessor or discrete logic for data logging. The force sensing membrane can also be electrically connected to a signal processing unit to provide an audio, visual, or
25 sensory (for example, vibration) response when a specified pressure threshold has been exceeded.

Arrays comprising a plurality of force sensing membranes of the invention can also be useful in healthcare applications. For example, an array of force sensing
30 membranes can be arranged at various locations in a bed to monitor pressure for the prevention of bedsores. The force sensing arrays can be uniformly or non-uniformly spaced.

Force sensing membranes of the invention are also useful, for example, in automotive applications (for example in seat sensors or for air bag deployment), consumer applications (for example, as load/weight sensors or in "smart systems" to sense the presence or lack thereof of an article on a shelf), manufacturing applications (for example, to monitor nip roll pressure), sporting applications (for example, to monitor speed, force or impact, or as grip sensors on clubs or racquets), and the like.

EXAMPLES

Objects and advantages of this invention are further illustrated by the following examples, but the particular materials and amounts thereof recited in these examples, as well as other conditions and details, should not be construed to unduly limit this invention.

Materials

Materials used in the examples are shown in the table below. The composition of the material is expressed in phr (parts per hundred parts of rubber). UC Silicone is vinyl modified poly dimethyl siloxane commercially available as Y-7942 from Crompton (Greenwich, CT); Pt catalyst is a dispersion of platinum fine powder available from Aldrich Canada (Oakville, ON, Canada) dispersed in the UC Silicone at 1 phr; DC1107 is a cross linker available from Dow Corning (Midland, MI); DM is dimethyl maleate commercially available from Fischer Scientific (Ottawa, ON, Canada); and silica is fumed silica available as M3 Cab-o-sil from Cabot Corporation (Tuscon, IL).

	UC Silicone (phr)	Pt catalyst (phr)	DC1107 (phr)	DM (phr)	Silica (phr)
SMHV 3	100	0.33	1.10	0.90	0
SMHV-3S	100	0.33	2.10	0.90	2
SMHV -9	100	0.33	0.39	0.26	0
SMHV-16	100	0.33	0.80	0.60	0

G165730N was blend of Kraton™ G1657 (available from Kraton Polymers, Houston, TX) and 30 phr of Nyflex 22b processing oil (available form Nynas USA Inc., Houston, TX).

5

Testing unit

The sensor was evaluated using an apparatus called the force apparatus, which consists of a load cell (model LCFD-1kg from Omega Engineering Inc., Hartford, CT) that measures the applied normal force on the sensor.

10

The sensor to be evaluated was placed on the load cell horizontally and secured with tape. A pneumatically operated cylinder (model E9X 0.5N from Airpot Corporation, Norwalk, CT) connected to two valves (model EC-2-12 from Clippard Instrument Laboratory, Cincinnati, OH), under computer control with compressed air at about 275 kPa, was located directly above the load cell. By opening and closing the valves in a sequence, the cylinder was moved downwards in pre-determined constant steps to increase the force on the sensor which was placed on the load cell. The load cell was connected to a display device (Model DP41-S-A available form Omega Engineering Inc. Hartford, CT) that displayed the applied force. Once a pre-determined limit of the force was reached, the air was vented from the system using a vent valve to reduce the force on the sensor.

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The conductors of the sensor were connected to a multimeter to record the sensor's electrical response. The resistance of the sensor was measured using a digital

multimeter (Keithley Model 197A microvolt DMM from Keithley Inc., Cleveland, OH). The applied force as read from the load cell and the electrical response of the sensor as read from the multimeter were captured with a PC based data acquisition system. The force applied ranged from 0.1 to 10 newton, and the application of force was done at a rate of about 0.028 newton/s (1.67 newton/min).

Explanation of n-value

When the resistance across a force sensor is measured, the response of resistance versus force can be plotted in a log-log plot. In a certain range, the power law relation can be given by the formula: $\text{resistance} = A/F^n$, where A is a constant, F is force, and n (the "n-value") is the slope of the best-fit line (determined by linear regression) on log-log plot. The n-value indicates the sensitivity of the sensor. The higher the n-value, the larger the change in resistance of the sensor for a given change in applied force. A lower n-value means a smaller change in resistance for the same change in applied force.

Explanation of R^2

As described above, the response of resistance versus force can be plotted in a log-log plot, and the best-fit line can be determined. As is known in the art, the degree of fit (or measure of goodness of fit) of the linear regression can be indicated by an R^2 value. R^2 is a fraction between 0.0 and 1.0. The closer R^2 is to 1.0, the better the fit. When R^2 is 1.0, all plotted points lie exactly in a straight line with no scatter.

Example 1

Indium tin oxide (ITO) coated glass fibers, commercially available as SD220 from 3M Company (St. Paul, MN), were dispensed over an uncured, knife coated layer (about 25 microns thick) of 734-silicone rubber (Dow Corning, Midland, MI). A particle dispenser as described in U.S. Patent App. Pub. No. 03/0129302 (Chambers et al.) was used to dispense the particles. After the silicone rubber was cured at room temperature over night, a small piece (approximately 20 mm x 20 mm) of the particle-embedded silicone rubber was cut and was transferred onto a copper foil tape (3M 1190, 3M Company, St. Paul, MN) and secured using 3M Scotch™ tape by applying the tape around the edges of the particle-embedded silicone. Another copper foil tape was placed on top of this ensuring that the two copper foils did not come in contact with each other. The two copper foils were electrically isolated from each by the Scotch™ tape.

The resulting sensor was tested using the force apparatus testing unit described above. The test data plotted on a log-log plot is shown in **Figure 6**. The n-value of the best-fit line is 1.02 and R^2 is 0.992.

Example 2

The sensor described in Example 1 was tested for its durability by repeating loading and unloading cycles as follows.

A Life cycle Test System (model 933A from Tricor Systems Inc., Elgin, IL) was used to test the sensor in terms of endurance. The test system has a pneumatically controlled cylinder, which pressed the sensor at a selected rate while counting the up/down number of cycles. The multimeter connected across the sensor measured the voltage

appearing across it. The sensor was tested for 1000 cycles and was seen to produce approximately the same voltage versus the force curves for each cycle.

5 Example 3

 The sensor described in Example 1 was connected to a LED (light emitting diode) bar graph display circuit. Applying a force on the sensor by pressing on it with a finger caused the display to light up a segment of the LED
10 in response to the applied force.

Example 4

 The characteristics of sensors essentially the same as that described in Example 1 were measured as described above
15 using the force apparatus testing unit after placing different overlay materials on the sensor. The overlay material was simply placed on top of the sensor. The overlays included:

- 20 1. Melinex™ polyester film (DuPont, Hopewell, VA);
 and
2. Equate™ foam cushion insoles, 140 mil thick
 (National Home Products Ltd., Downsview,
 Ontario, Canada)

 The sensor characteristics were essentially unchanged
25 on the application of the overlayers as shown in Table 1 (polyester film) and Table 2 (foam insoles). The n-values show that placing different overlayers on top of the sensor did not significantly alter the sensitivity of the sensor.

Table 1 - Polyester Overlayer

	Condition	n	R ²
1	No overlayer	1.48	0.960
2	PET 10 mil overlayer	1.58	0.987
3	PET 14 mil overlayer	1.49	0.979
4	PET 20 mil overlayer	1.48	0.984

Table 2 - Foam Insoles Overlayer

5

	Condition	n	R ²
1	No overlayer	1.15	0.990
2	With foam over layer	1.12	0.933

Example 5

To analyze the affect of an air gap between the conductor and the composite material layer, 3M 810 tape (St. Paul, MN) was used to build up a space between the silicone rubber layer and the top copper foil tape of a sensor essentially the same as that described in Example 1. The sensor was tested using the force apparatus testing unit with air gap thicknesses listed below. The results (in Table 3) show that as the air gap was increased, the sensitivity of the sensor was increased as shown by the increased n-value.

Table 3

20

	Spacing (micron)	n	R ²
1	0	1.7	0.982
2	187.5	1.7	0.982
3	375	3.3	0.961
4	562.5	4.2	0.907

Example 6

Sensors were prepared essentially as described in Example 1 except with the elastomer shown below and with

indium tin oxide (ITO) coated glass beads instead of the fibers. Indium tin oxide (ITO) coated glass beads, commercially available as SD110 from 3M Company (St. Paul, MN), were dispensed over an uncured, knife coated layer of the elastomer indicated below about 1 mil (25 micron) thick. The sensors were tested using the force apparatus testing unit. The activation force of the sensors (F_i), defined as the force necessary to show a resistance of 1 kOhm was also recorded.

10

Table 4

	Elastomer	G' (Pa)	Tan delta	F_i (kg)	n
1	Dow Corning 734	2.0×10^5	0.05	0.150	1.4
2	SMHV-3S	2.0×10^5	0.01	0.150	1.1
3	G5730N	2.5×10^5	0.15	0.250	2.4

Example 7

15

An elastomer of interest (shown in Table 5 as "bottom" elastomer) was knife coated onto a conducting layer of ITO coated polyester to obtain a 37.5 micron (1.5 mil) thickness. ITO coated glass beads were dispensed onto the elastomer layer at roughly 1.5 g/ft² density. The particles were embedded into the elastomeric layer by nipping the coated elastomer between two rubber rolls. This coated elastomer was cured in air at 120°C for 5 minutes in an oven. On a separate conductive layer of ITO coated polyester, an elastomer (shown in Table 5 as "top" elastomer) was knife coated to a thickness of 12.5 micron (0.5 mil), and the elastomer was cured for 5 minutes in air at 120°C in an oven. The two layers were brought together such that the elastomers were facing each other, and were then taped together with packaging tape (3M 3710 tape, 3M

20

25

Company, St. Paul, MN). Electrical connections were made to the two conducting layers using copper electrical foil tape (3M 1190, 3M Company, St. Paul, MN) and the sensors were testing using the force apparatus testing unit. The results are shown in Table 5.

The G' and tan delta of the top elastomer layer with the activation force (F_i) of each sensor, defined as the force necessary to show a resistance of 1 kOhm, and the n-value are shown in the Table. Higher modulus elastomers showed high activation force and higher n-values, thus higher sensitivity to force.

Table 5

	Elastomer (top/bottom)	Top G' (Pa)	Top Tan delta	F_i (kg)	n
1	SMHV16/SMHV16	0.5 x 10 ⁵	0.04	0.030	0.97
2	SMHV16/G5730N			0.030	0.94
3	SMHV3/SMHV16	2.0 x 10 ⁵	0.01	0.120	1.4
4	SMHV3/G5730N			0.090	1.3

Various modifications and alterations to this invention will become apparent to those skilled in the art without departing from the scope and spirit of this invention. It should be understood that this invention is not intended to be unduly limited by the illustrative embodiments and examples set forth herein and that such examples and embodiments are presented by way of example only with the scope of the invention intended to be limited only by the claims set forth herein as follows.

We claim:

1. A force sensing membrane comprising:

5 (a) a first conductor that is movable toward a second conductor;

(b) a second conductor;

10 (c) a composite material disposed between the first and second conductors for electrically connecting the first and second conductors under application of sufficient pressure therebetween; and

(d) means for measuring dynamic electrical response across the force sensing membrane,

the composite material comprising conductive particles at least partially embedded in an elastomeric layer,

15 the conductive particles having no relative orientation and being disposed so that substantially all electrical connections made between the first and second conductors are in the z direction, and

20 the elastomeric layer being capable of returning to substantially its original dimensions on release of pressure.

25 2. The force sensing membrane of claim 1 wherein the elastomeric layer comprises an elastomeric material that has a substantially constant G' between about 0°C and about 100°C .

30 3. The force sensing membrane of claim 2 wherein the elastomeric layer comprises an elastomeric material that has a substantially constant G' between about 0°C and about 60°C .

4. The force sensing membrane of claim 1 wherein the elastomeric layer comprises an elastomeric material that has a G' between about 1×10^3 Pa/cm² and about 9×10^5 Pa/cm² and a loss tangent between about 0.01 and about 0.60 at 1 Hz at 23°C.

5. The force sensing membrane of claim 1 wherein the elastomeric layer comprises an elastomeric material that is self-healing.

6. The force sensing membrane of claim 1 wherein the elastomeric layer comprises an elastomeric material selected from the group consisting of silicones and styrenic block copolymers.

7. The force sensing membrane of claim 6 wherein the elastomeric layer comprises a silicone.

8. The force sensing membrane of claim 6 wherein the elastomeric layer comprises styrene-isoprene-styrene block copolymers or styrene-ethylene/butylene-styrene block copolymers.

9. The force sensing membrane of claim 1 wherein the conductive particles are disposed so that substantially all electrical connection made between the first and second conductors are through single particles.

10. The force sensing membrane of claim 9 wherein the conductive particles are disposed so that no more than two particles are in contact with each other.

11. The force sensing membrane of claim 10 wherein no two particles are in contact with each other.

5 12. The force sensing membrane of claim 1 wherein the conductive particles comprise a metal.

10 13. The force sensing membrane of claim 1 wherein the conductive particles comprise core particles having a conductive coating.

14. The force sensing membrane of claim 13 wherein the core particles comprise glass particles.

15 15. The force sensing membrane of claim 13 wherein the core particles comprise hollow particles.

16. The force sensing membrane of claim 13 wherein the conductive coating comprises metal.

20 17. The force sensing membrane of claim 13 wherein the conductive coating comprises a conductive oxide.

25 18. The force sensing membrane of claim 1 wherein the conductive particles are substantially spherical.

19. The force sensing membrane of claim 1 wherein the conductive particles are fibers.

30 20. The force sensing membrane of claim 1 wherein the first and second conductors are disposed on first and second substrates respectively.

21. The force sensing membrane of claim 20 wherein at least one of the first and second substrates is flexible.

22. The force sensing membrane of claim 1 further comprising an overlay layer disposed on the first or second conductor.

23. The force sensing membrane of claim 1 wherein there is a gap between the composite material and one of the first and second conductors.

24. The force sensing membrane of claim 1 wherein the composite material further comprises non-conducting fillers.

25. The force sensing membrane of claim 1 wherein the thickness of the membrane is between about 1 μm and about 500 μm .

26. The force sensing membrane of claim 25 wherein the thickness of the membrane is between about 1 μm and about 50 μm .

27. A force sensing membrane comprising:

(a) An elastomeric layer disposed on a first conductor; and

(b) a composite material comprising conductive particles at least partially embedded in an insulating material disposed on a second conductor;

at least one of the first and second conductors being movable toward the other conductor,

the conductive particles electrically connecting the first and second conductors under application of sufficient pressure therebetween,

5 the conductive particles having no relative orientation and being disposed so that substantially all electrical connections made between the first and second conductors are in the z direction, and

10 the elastomeric layer being capable of returning to substantially its original dimensions on release of pressure.

15 28. The force sensing membrane of claim 27 wherein the insulating material is capable of returning to substantially its original dimensions on release of pressure.

20 29. The force sensing membrane of claim 27 wherein one or both of the elastomeric layer and the insulating material comprises an elastomeric material that has a substantially constant G' between about 0°C and about 100°C .

25 30. The force sensing membrane of claim 27 wherein one or both of the elastomeric layer and the insulating material comprises an elastomeric material that has a substantially constant G' between about 0°C and about 60°C .

30 31. The force sensing membrane of claim 27 wherein one or both of the elastomeric layer and the insulating material comprises an elastomeric material that has a G' between about $1 \times 10^3 \text{ Pa/cm}^2$ and about $9 \times 10^5 \text{ Pa/cm}^2$ and a loss tangent between about 0.01 and about 0.60 at 1 Hz at 23°C .

32. The force sensing membrane of claim 27 wherein one or both of the elastomeric layer and the insulating material

comprises an elastomeric material that is self-healing.

33. The force sensing membrane of claim 27 wherein the
conductive particles are disposed so that substantially all
5 electrical connections made between the first and second
conductors are through single particles.

34. The force sensing membrane of claim 33 wherein the
conductive particles are disposed so that no more than two
10 particles are in contact with each other.

35. The force sensing membrane of claim 34 wherein no
two particles are in contact with each other.

15 36. The force sensing membrane of claim 27 wherein the
thickness of the composite layer is less than the average
conductive particle size.

37. The force sensing membrane of claim 36 wherein at
20 least some of the conductive particles are always in contact
with the second conductor.

38. The force sensing membrane of claim 27 further
comprising means for measuring dynamic electrical response
25 across the force sensing membrane.

39. A device comprising the force sensing membrane of
claim 1.

30 40. The device of claim 39 wherein the device is
incorporated into a sock, bandage, or insole.

41. A device comprising an array of a plurality of the force sensing membranes of claim 1.

5 42. A device comprising the force sensing membrane of claim 27.

43. The device of claim 42 wherein the device is incorporated into a sock, bandage, or insole.

10 44. A device comprising an array of a plurality of the force sensing membranes of claim 27.

45. A method of force sensing comprising applying pressure to the force sensing membrane of claim 1, and
15 measuring the change in an electrical property across the force sensing membrane.

46. A method of force sensing comprising:

20 (a) electrically connecting the first and second conductors of the force sensing membrane of claim 27 to a means for measuring dynamic electrical response, and

(b) measuring an electrical response across the force sensing membrane.

25

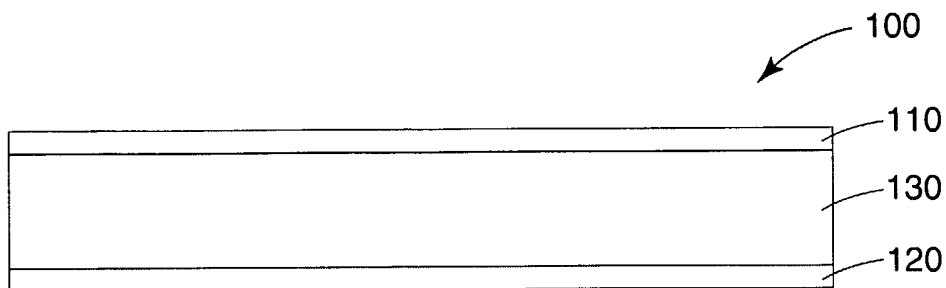


Fig. 1

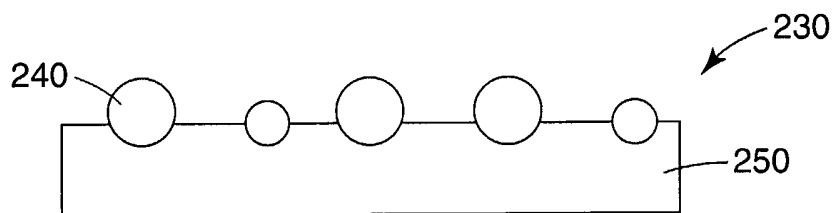


Fig. 2a

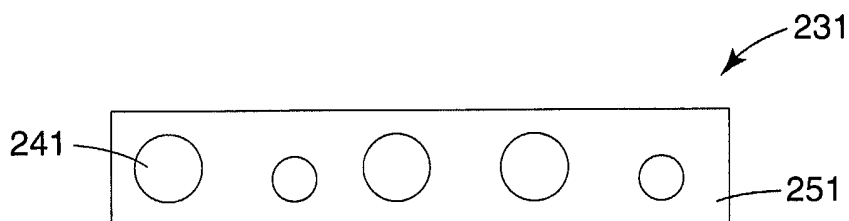


Fig. 2b

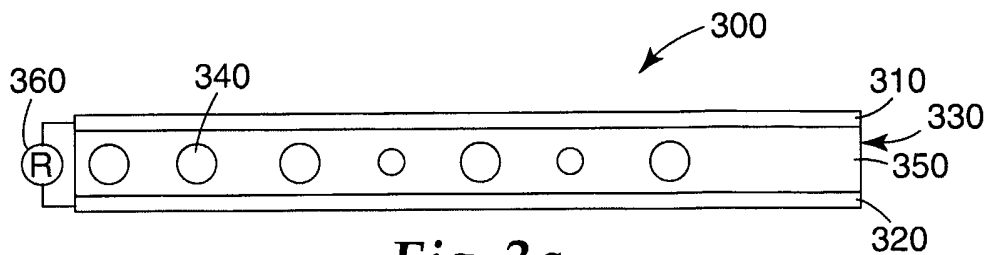


Fig. 3a

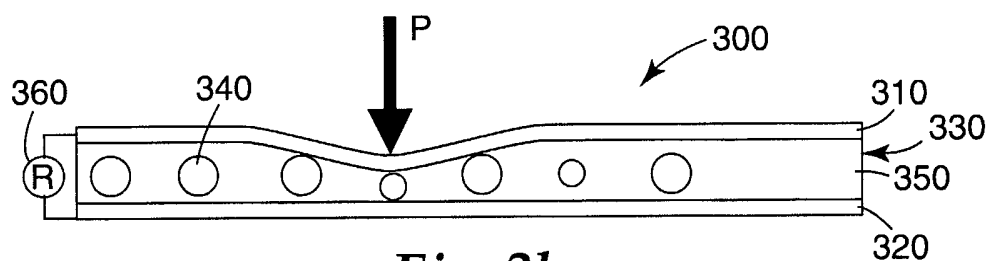


Fig. 3b

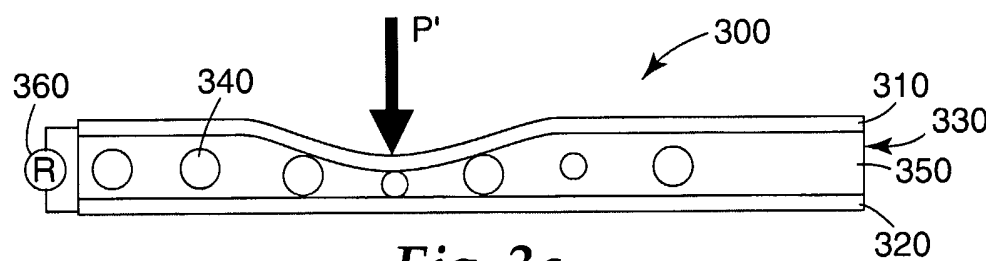


Fig. 3c

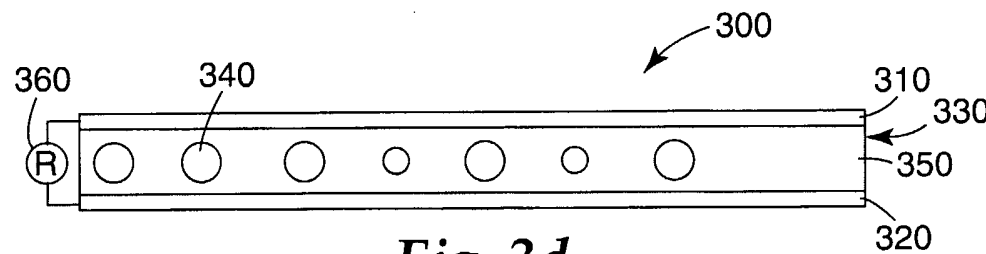
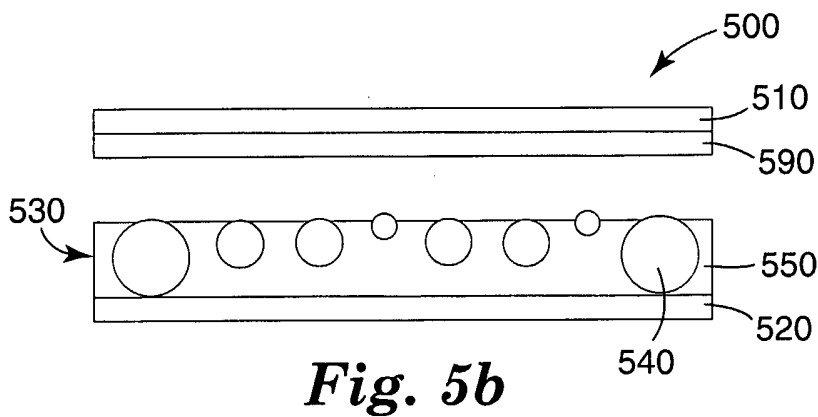
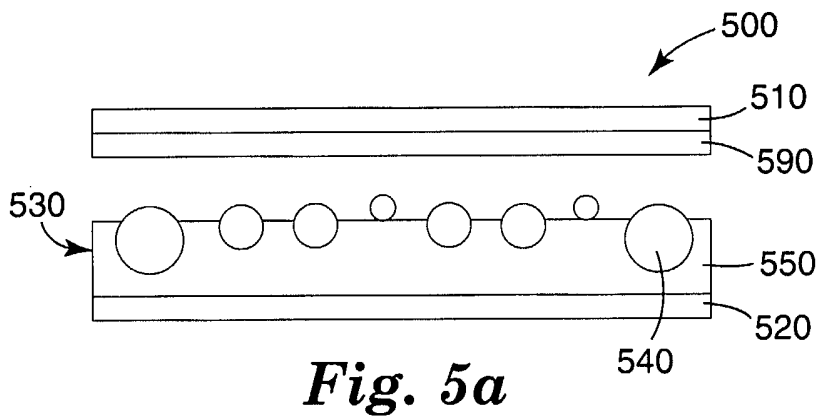
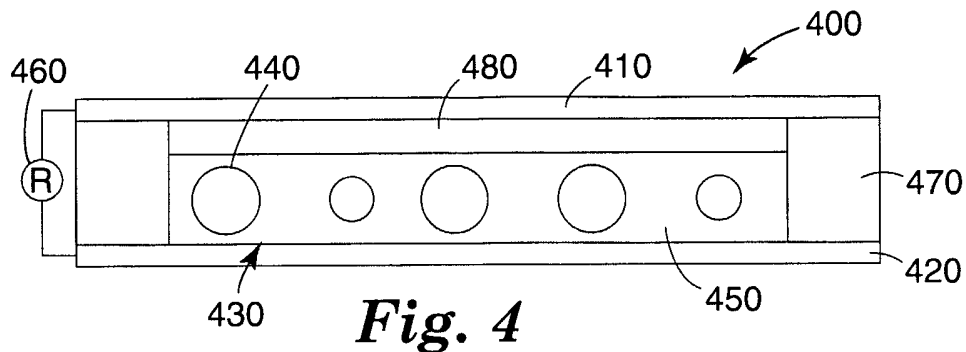


Fig. 3d



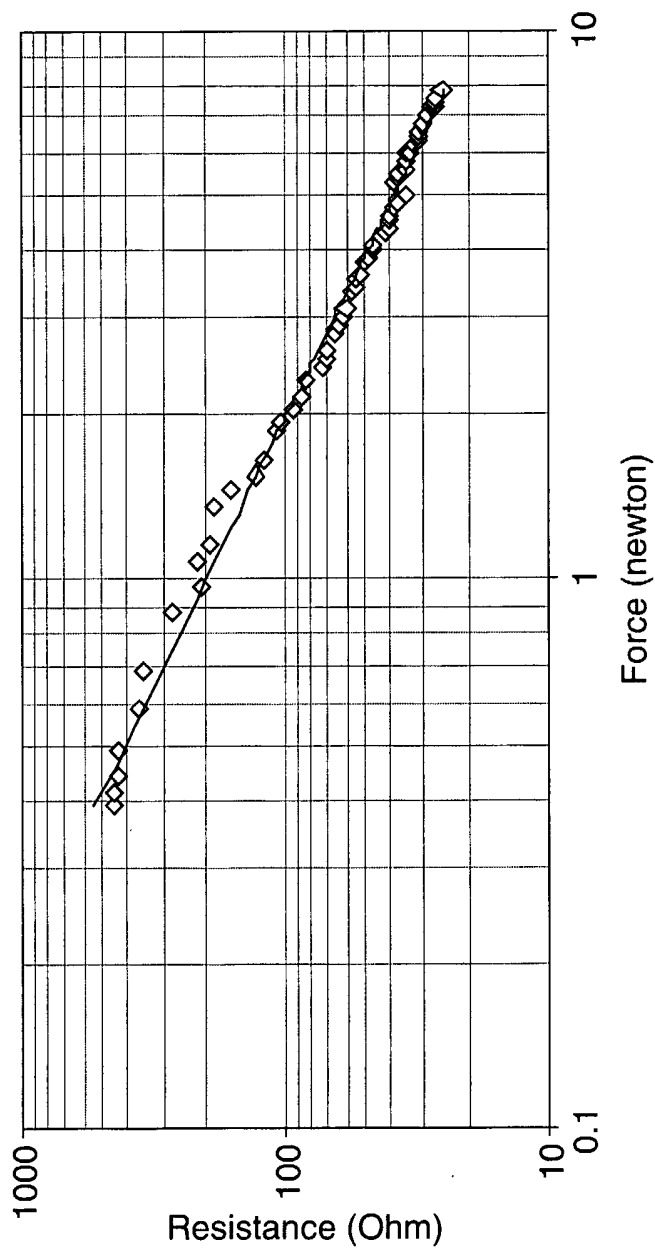


Fig. 6

INTERNATIONAL SEARCH REPORT

International application No
PCT/US2005/046434

A. CLASSIFICATION OF SUBJECT MATTER INV. G01L1/20 H01H1/029		
According to International Patent Classification (IPC) or to both national classification and IPC		
B. FIELDS SEARCHED		
Minimum documentation searched (classification system followed by classification symbols) G01L H01H		
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched		
Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, PAJ, WPI Data		
C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 2003/205450 A1 (DIVIGALPITIYA RANJITH ET AL) 6 November 2003 (2003-11-06) the whole document	1-4, 6-39, 41, 42, 44-46
X	US 5 302 936 A (YANIGER ET AL) 12 April 1994 (1994-04-12) abstract claims 7,9 figure 2	1, 27, 45
X	JP 2001 228975 A (FUJIKURA LTD) 24 August 2001 (2001-08-24) figure a	1, 27, 45
-/--		
<input checked="" type="checkbox"/> Further documents are listed in the continuation of Box C.		
<input checked="" type="checkbox"/> See patent family annex.		
* Special categories of cited documents :		
A document defining the general state of the art which is not considered to be of particular relevance *E* earlier document but published on or after the international filing date *L* document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) *O* document referring to an oral disclosure, use, exhibition or other means *P* document published prior to the international filing date but later than the priority date claimed		
** later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention *X* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone *Y* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art. *&* document member of the same patent family		
Date of the actual completion of the international search <p align="center">7 April 2006</p>		Date of mailing of the international search report <p align="center">19/04/2006</p>
Name and mailing address of the ISA/ European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016		Authorized officer <p align="center">Cilissen, M</p>

INTERNATIONAL SEARCH REPORT

International application No
PCT/US2005/046434

C(Continuation). DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
	<p>& PATENT ABSTRACTS OF JAPAN vol. 2000, no. 25, 12 April 2001 (2001-04-12) & JP 2001 228975 A (FUJIKURA LTD), 24 August 2001 (2001-08-24) abstract -----</p>	

INTERNATIONAL SEARCH REPORT

Information on patent family members

International application No

PCT/US2005/046434

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